

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kevin J. Orvek et al.

Serial No. : 10/814,883

Filed : March 31, 2004

Patent No. : 7,242,020

Issue Date : July 10, 2007

Title : REAL-TIME MONITORING OF PARTICLES IN SEMICONDUCTOR  
VACUUM ENVIRONMENT

Art Unit : 2823

Examiner : Jarrett J. Stark

Conf. No. : 7571

**Mail Stop Express Abandonment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**EXPRESS ABANDONMENT UNDER 37 CFR §1.138**

Applicant hereby expressly abandons application serial number 10/814,883, filed March 31, 2004 in favor of co-pending application serial numbers 11/773,197 and 11/773,220, filed July 3, 2007, which are directed to the same subject matter. This abandonment is made without prejudice and is not intended as an abandonment of the subject matter disclosed and claimed in this application.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date:

July 9, 2007

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